

**AFFIDAVIT OF MR. JONATHAN HICKS IN SUPPORT OF
MOTION FOR *PRO HAC VICE* ADMISSION**

I, Jonathan Hicks, being duly sworn and upon oath, hereby attests to the following:

1. I am a member in good standing of the Bar of California and the Bar of Nevada, as well as the following Federal Courts:

- a) Northern District of California
- b) Eastern District of California

2. I have not been suspended or disbarred from practice before any court or administrative body;

3. I have never had an application for admission to practice before any court or administrative body denied;

4. No sanction or contempt citation has been imposed against me by any court or administrative body;

5. I have read and will comply with the Office Patent Trial Practice Guide and the Board's Rules of Practice for Trials set forth in part 42 of the C.F.R.;

6. I will be subject to the USPTO Code of Professional Responsibility set forth in 37 C.F.R. §§ 11.101 *et seq.* and disciplinary jurisdiction under 37 C.F.R. § 11.19(a);

7. In the last three (3) years, I have applied to appear pro hac vice before the Office in four proceedings, including IPR2013-00312; IPR2014-01445; IPR2014-01446; and IPR2014-01447; and

8. I am an experienced litigation attorney, with experience in numerous litigations involving patent infringement in District Courts across the country, including experience in jury and bench trials, and Markman hearings. I am counsel for Samsung Electronics Co., Ltd., Samsung Electronics America, Inc., and Samsung Telecommunications America, LLC (collectively “Samsung”) in a pending litigation in which U.S. Patent No. 6,009,469 is being asserted by Straight Path IP Group, Inc. I am familiar with the subject matter at issue in this proceeding as a result, including the prior art on which Petitioner relies in this request, as well as the issues of claim construction.

